

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KOBAYASHI

Application No.: 10/563,302

Filed: 1/4/2006

Title: ELECTROSTATIC CHUCK FOR SUBSTRATE STAGE, ELECTRODE USED  
FOR THE CHUCK, AND TREATING SYSTEM HAVING THE CHUCK AND  
ELECTRODE

Art Unit: 2836

Exr.: T. MAI

CONF. No.: 8395

**PRELIMINARY AMENDMENT**

**MS: AMENDMENT**

**June 26, 2009**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as listed  
below and as set forth on the following pages:

**Amendments to the Claims;**

**Remarks are included following the amendments.**